

Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DKT. NO. 520.43558X00	SERIAL NO. 10/790,190
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		APPLICANT ODA, et al.	
		FILING DATE March 2, 2004	GROUP 2818

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					

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Examiner Initial	Document Number	Date	Country	Class	Subclass	Abstract	
						Yes	No
TH	AM	9-283533	10/31/1997	JP	H01L 21/331	X	
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TH	AU	J. Kouvetakis, et al., "Novel Chemical Routes to Silicon-Germanium-Carbon Materials", Appl. Phys. Lett., Vol. 65, No. 23, December 5, 1994, Pgs. 2960-2962
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Examiner		Date Considered
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